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Ruth Montalvo

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In the event that this paper is late filed and a necessary Petition for an Extension of Time is not concurrently filed herewith, please consider this as a Petition for the requisite extension of time, and to the extent not tendered by check attached hereto, authorization to charge the extension fee, or any other fee required in connection with this paper, to Deposit Account No. 50-1529.

Docket No.: GK-OEH-178 500814-20080

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Customer No. 26418

Applicant: Duc Chinh Tran

Serial No.: 10/784,438

Group Art Unit: 2851 Examiner: Della J. Rutledge

Filed: February 23, 2004

For: Arrangement For Debris Reduction in a Radiation Source Based on a Plasma

AMENDMENT

Commissioner for Patents
P.O Box 1450
Alexandria, VA 22313-1450

Sir:

In response to an Office Action dated September 14, 2005, please amend the above-identified application as follows.